

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	Examiner: C. E. Church
Yoshinori OHSAKI)	
A 12 12 N. 00/577 (00	:	Group Art Unit: 2882
Application No.: 09/577,608) :	Confirmation No.: 6496
Filed: May 25, 2000)	
For: POSITIONING APPARATUS, ATMOSPHERE)	January 20, 2004
SUBSTITUTING METHOD, EXPOSURE APPARATUS, AND DEVICE MANUFACTURING METHOD	: ()	((Tuesday after Federal Holiday)
METHOD	•	~! (T)
		REC JAN TECHNOLOG
Commissioner for Patents		
P.O. Box 1450		
Alexandria, VA 22313-1450		K N H
		RECEIVED JAN 22 2004 OLGGY CENTER
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<u>AMENDMENT</u>		80

Sir:

In response to the Official Action dated October 17, 2003, the time to respond to which having been extended to Tuesday, January 20, 2004 a day after a Federal Holiday, please amend the above-identified application as follows: